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Date : June 3, 2009
TO : Director, Office of Data Management
FROM : Office of Petitions
SUBJECT : Withdrawal from Issue of **Application No. 10/815,287**

Applicant(s) : Soon-Il Ahn, et al.
Application No. : 10/815,287
Filed : April 1, 2004

The above-identified application has been assigned Patent No. 7,544,526 and an issue date of June 9, 2009.

It is hereby directed that this application be withdrawn from issue at the request of the applicant. Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of June 9, 2009:

"All reference to Patent No. 7,544,526 to SOON-IL AHN, ET AL. of REPUBLIC OF KOREA for METHOD OF EXPOSING LAYER WITH LIGHT AND METHOD OF MANUFACTURING THIN FILM TRANSISTOR SUBSTRATE FOR LIQUID CRYTAL DISPLAY DEVICE USING THE SAME appearing in the Official Gazette of June 9, 2009 should be deleted since no patent was granted."

/SDB/

Sherry D. Brinkley
Petitions Examiner
Office of Petitions

cc: Paul Harrison
Deneise Boyd
Mary Louise McAskill
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